

PATENT ASSIGNMENT

Electronic Version v1.1
 Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
Name	Execution Date
MASSACHUSETTS INSTITUTE OF TECHNOLOGY	11/15/2002
RECEIVING PARTY DATA	
Name:	National Institutes of Health (NIH), U.S. Dept. of Health and Human Services (DHHS), U.S. Government
Street Address:	NIH Division of Extramural Inventions and Technology Resources (DEITR)
Internal Address:	6705 Rockledge Drive, Suite 310, MSC 7980
City:	Bethesda
State/Country:	MARYLAND
Postal Code:	20892-7980
PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	10282905
CORRESPONDENCE DATA	
Fax Number:	(301)480-0272
<i>Correspondence will be sent via US Mail when the fax attempt is unsuccessful.</i>	
Email:	edison@nih.gov
Correspondent Name:	Director, DEITR
Address Line 1:	NIH, 6705 Rockledge Drive, Suite 310
Address Line 2:	MSC 7980
Address Line 4:	Bethesda, MARYLAND 20892-7980
NAME OF SUBMITTER:	Director,DEITR, NIH
Total Attachments: 1 source=10282905mrs-p0001 - p0002#page2.tif	

10/282,905

LICENSE TO THE UNITED STATES GOVERNMENT

This instrument confers to the United States Government, as represented by the Department of Health and Human Services, a nonexclusive, nontransferable, irrevocable, paid-up license to practice or have practiced on its behalf throughout the world the following subject invention, patent application and any and all divisions or continuations, and any resulting patent or reissues which may be granted thereon:

M.I.T. Case No.: 9434
Invention Title: "Fluorocarbon-Organosilicon Copolymers by Hot-Filament CVD"
Inventor(s): Karen Gleason and Shanshi K. Murthy
Serial No.: 10/282,905
Filing Date: October 29, 2002
Title: "Fluorocarbon-Organosilicon Copolymers and Coatings Prepared by Hot-Filament Chemical Vapor Deposition"

This subject invention was conceived or first actually reduced to practice in performance of a government-funded project, National Institutes of Health Grant No. N01-NS-9-2323

Principal rights to this subject invention have been left with the Licensor: MASSACHUSETTS INSTITUTE OF TECHNOLOGY, subject to the provisions of 37 CFR 401 and 45 CFR 8.

Signed this 15th day of November 2002.

MASSACHUSETTS INSTITUTE OF TECHNOLOGY

By



Deborah Burke
Patent Compliance Administrator
Technology Licensing Office

77 Massachusetts Avenue, Room NE25-230, Cambridge, MA 02139

PATENT

RECORDED: 09/08/2008

REEL: 021493 FRAME: 0284